



01-11-00

GP1746/18

ATMI-272
PATENT APPLICATIONIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: **Van Buskirk et al.**Serial No.: **09/093,291**Date Filed: **June 8, 1998**Title: **Isotropic Dry Cleaning
Process for Noble Metal
Integrated Circuit Structures**Examiner: **A. Olsen**Group Art Unit: **1746**4/10
1/27/00EXPRESS MAIL CERTIFICATE

I hereby certify that I am mailing the attached documents to the Assistant Commissioner for Patents on the date specified below, in an Express Mail envelope addressed to the Assistant Commissioner for Patents, Washington, DC 20231, and Express Mailed under the provisions of 37 CFR 1.10.

Jacqueline Bagwell

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AMENDMENT RESPONDING TO OCTOBER 8, 1999 OFFICE ACTION IN
U.S. PATENT APPLICATION NO. 09/093,291Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the October 8, 1999 Office Action in the above-identified United States Patent Application (the "Office Action"), please amend the application as follows:

In the specification:

01/13/2000 ASAMLE 00000019 09093291

01 FC:203
02 FC:20227.00 OP
117.00 OP

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